

Appl. No. 09/894,717 Amdt. dated May 5, 2003 Reply to Office action of December 3, 2002

This listing of claims will replace all prior versions, and listings, of claims in the application:

## **Listing of Claims**

Claim 1 (currently amended): A semiconductor with integrated monitoring comprising:

- a first <u>light emitting</u> semiconductor <u>device</u> formed on a predetermined substrate;
- a passivation layer formed on top of said first semiconductor device, said passivation layer including a window; and
- a <u>light</u> monitoring device formed on top of said passivation layer <u>for monitoring leakage</u> <u>light from said first semiconductor device through said window</u>.

Claim 2 (original): The semiconductor as recited in claim 1, wherein said first semiconductor device is an active device.



Claim 3 (currently amended): A <u>The</u> semiconductor with integrated monitoring comprising:
a first semiconductor formed on as recited in claim 1, wherein said predetermined
substrate is a GaAs substrate;
a passivation layer formed on top of said-first semiconductor device; and
a monitoring device formed on top of said-passivation layer.
Claim 4 (currently amended): A <u>The</u> semiconductor with integrated monitoring comprising:
- a first semiconductor formed on as recited in claim 1, wherein said predetermined
substrate is a InP substrate;
a passivation layer formed on top of said first semiconductor device; and
— a monitoring device formed on top of said passivation layer.
Claim 5 (currently amended): A <u>The</u> semiconductor with integrated monitoring comprising:
a first semiconductor formed on as recited in claim 1, wherein said predetermined
substrate is a GaN substrate;
- a passivation layer formed on top of said first semiconductor device; and

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a monitoring device formed on top of said passivation layer.

Claim 6 (cancelled)

Claim 7 (original): The semiconductor as recited in claim 1, wherein said first semiconductor device is a light emitting device.

Claim 8 (original): The semiconductor as recited in claim 6, wherein said light emitting device is a laser.

Claim 9 (original): The semiconductor as recited in claim 8, wherein said laser is a vertical cavity surface emitting laser (VCSEL).

Claim 10 (original): The semiconductor as recited in claim 1, wherein said monitoring device is a light transmitting device.

Claim 11 (original): The semiconductor as recited in claim 1, wherein said monitoring device is a light receiving device.

Claim 12 (original): The semiconductor as recited in claim 10, wherein said light transmitting device is a photodiode.

Claim 13 (original): The semiconductor as recited in claim 11, wherein said light receiving device is a photodetector.

Claims 14-22 (cancelled)